



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the Application of:

SHIRATA, Yosuke

Group Art Unit: **2851**

Serial No.: **09/684,898**

Examiner: **NGUYEN, H.**

Filed: **October 10, 2000**

P.T.O. Confirmation No.: **2212**

For: **LITHOGRAPHY SYSTEM AND METHOD**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: August 11, 2003

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated February 18, 2003 for three months from May 18, 2003 to August 18, 2003.

Attached please find a check in the amount of \$930.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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PATENT TRADEMARK OFFICE